



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: **Zhang et al.**

Serial No: **09/357264**

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For: **COMP. FOR CHEMICAL  
MECHANICAL  
PLANARIZATION OF COPPER,  
TANTALUM AND TANTALUM  
NITRIDE**

Examiner: **Matthew J. Song**

Art Unit: **1765**

**RESPONSE TO OFFICE ACTION**

**MAIL STOP AMENDMENT  
COMMISSIONER OF PATENTS  
P.O. Box 1450  
ALEXANDRIA, VA 22313-1450**

Dear Sir:

This paper responds to the Office Action dated September 17, 2004. Please enter the following:

**CLAIMS AMENDMENTS:** Begin on Page 2

**SPECIFICATION AMENDMENTS:** None

**FIGURES AMENDMENTS:** None

**REMARKS SECTION:** Begins on Page 6